

FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office				Attorney Docket Number <b>5308-223CT</b>			Serial No. <b>To be assigned</b>
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b>  (Use several sheets if necessary)							
				<b>Applicants: Sumakeris et al.</b>			
				<b>Filing Date: Concurrently herewith</b>		<b>Group:</b>	
<b>U. S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
JF	1.	6,449,428	9/10/02	Aschner et al.	392	418	
	2.	6,406,983	06/2002	Holzlein et al.	438	522	
	3.	6,331,212	12/2001	Mezey, Sr., James J.	118	725	
	4.	6,299,683	10/2001	Rupp et al.	117	88	
	5.	6,239,418	5/29/01	Konig et al.	219	756	
	6.	6,217,662	04/2001	Kong et al.	118	725	
	7.	6,093,253	7/25/00	Löfgren et al.	118	725	
	8.	6,048,398	4/11/00	Vehanen et al.	117	200	
	9.	6,039,812	3/21/00	Ellison et al.	118	725	
	10.	6,030,661	2/29/00	Kordina et al.	427	248.1	
	11.	6,005,226	12/21/99	Aschner et al.	219	390	
	12.	5,879,462	3/09/99	Kordina et al.	118	725	
	13.	5,858,102	1/12/99	Tsai	118	719	
	14.	5,792,257	08/11/98	Kordina et al.	117	90	
	15.	5,788,777	8/04/98	Burk, Jr.	118	730	
	16.	5,759,263	6/02/98	Nordell et al.	117	98	
	17.	5,704,985	1/06/98	Kordina et al.	118	725	
	18.	5,695,567	12/09/97	Kordina et al.	118	725	
	19.	5,695,567	12/1997	Kordina et al.	118	725	
	20.	5,674,320	10/07/97	Kordina et al.	118	500	
	21.	5,674,320	10/1997	Kordina et al.	118	500	
	22.	5,558,721	9/24/96	Kohmura et al.	118	730	
	23.	5,468,299	11/21/95	Tsai	118	730	
✓	24.	5,226,383	07/13/93	Bhat	18	730	
✓	25.	5,119,540	6/09/92	Kong et al.	29	25.01	

EXAMINER  
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11/10/2005

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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LIST OF DOCUMENTS CITED BY APPLICANT  (Use several sheets if necessary)							
				Applicants: Sumakeris et al.			
				Filing Date: Concurrently herewith			Group:
JF	26.	5,108,540	04/28/92	Frijlink	156	612	
	27.	5,056,555	10/15/91	Frijlink	137	522	
	28.	5,027,746	07/02/91	Frijlink	118	724	
	29.	4,976,217	12/11/90	Frijlink	118	733	
	30.	4,961,399	10/09/90	Frijlink	118	730	
	31.	4,860,687	08/29/89	Frijlink	118	500	
	32.	4,860,687	08/1989	Frijlink, Peter M.	118	500	
	33.	4,845,332	07/1989	Jancosek et al.	219	645	
	34.	4,748,135	05/31/88	Frijlink	437	102	
	35.	4,722,911	02/02/88	Frijlink	437	110	
	36.	3,424,628	1/28/69	Wining	148	175	
↓	37.	20010002948A1	06/07/01	Aschner et al.	392	418	
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation Yes   No
JF	37.	0956376	8/28/97	EP	C23C	16/32	No
↓	38.	0519608	12/23/92	EP	C30B	25/12	No
↓							
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
JF	39.	Press Release, <i>Sterling Semiconductor Placed Order for Second EPIGRESS SiC CVD System</i> , 10/24/01, at <a href="http://www.compoundsilicon.net/PressReleases/2001/PR10240102.htm">http://www.compoundsilicon.net/PressReleases/2001/PR10240102.htm</a> .					
↓	40.	U.S. Patent Application Serial No. 09/756,548, filed January 8, 2001					
↓	41.	International Search Report for PC/US02/34090, dated May 19, 2003					

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